

INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO-1449	ATTY. DOCKET NO. 11113/9	SERIAL NO. To be assigned
	APPLICANT(S) WANG et al.	
	FILING DATE Herewith	GROUP <u>1772</u> To be assigned

1040 U.S. PTO
10/035561
11/07/01

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS/ SUBCLASS	FILING DATE
CB	4,331,697	May 25, 1982	Kudo et al.	427/2.11	—
	4,377,010	March 22, 1983	Fydeler et al.	3/1.4	—
	4,442,133	April 10, 1984	Greco et al.	427/2.25	—
	4,589,964	May 20, 1986	Mayhan et al.	522/85	—
	4,743,258	May 10, 1988	Ikada et al.	623/1.49	—
	4,978,481	December 18, 1990	Janssen et al.	264/1.32	—
	5,002,582	March 26, 1991	Guire et al.	427/2.24	—
	5,069,899	December 3, 1991	Whitbourne et al.	424/56	—
	5,211,993	May 18, 1993	Kolesinski	427/488	—
	5,447,799	September 5, 1995	Loh et al.	428/448	—
	5,453,467	September 26, 1995	Bamford et al.	525/287	—
	5,525,348	June 11, 1996	Whitbourne et al.	424/423	—
	5,663,237	September 2, 1997	Lee et al.	525/285	—
	5,741,551	April 21, 1998	Guire et al.	427/407.1	—
	5,782,908	July 21, 1998	Cahalan et al.	623/1.13	—
↓	6,013,855	January 11, 2000	McPherson et al.	623/23.76	—
CB	6,096,369	August 1, 2000	Anders et al.	427/2.3	—

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION	
					YES	NO

10/035,52d

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
CB	C.-M. Chan et al., "Polymer surface modification by plasmas and photons", <i>Surface Science Reports</i> , 24 (1996) 1-54.
CD	R.R. Rye, "Radiation Hardening of Polytetrafluoroethylene Against Chemical Etching", <i>Journal of Polymer Science: Part B: Polymer Physics</i> , Vol. 26, 2133-2144 (1988)
CB	<i>Polymer Surfaces From Physics to Technology</i> , John Wiley & Sons, (1994) pp.223-273.
CB	M.P. Stevens, <i>Polymer Chemistry an Introduction</i> , (1975) pp.196-203.
CB	Shen et al., "A Kinetic Study on MMA Bulk Radical Polymerization", <i>Polymer International</i> , 28, (1992) 75-79.

EXAMINER <u>CL-B</u>	DATE CONSIDERED <u>8/16/04</u>
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with M.P.E.P. 609; strike out citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	



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	C.-M. Chan et al., "Polymer surface modification by plasmas and photons", <i>Surface Science Reports</i> , 24 (1996) 1-54.
	R.R. Rye, "Radiation Hardening of Polytetrafluoroethylene Against Chemical Etching", <i>Journal of Polymer Science: Part B: Polymer Physics</i> , Vol. 26, 2133-2144 (1988)
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